

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Takeshi Fukada Art Unit : Unknown
Serial No. : New Divisional Application Examiner : Unknown
Filed : September 8, 2003
Title : SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE
SAME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Under 35 USC §120, this application relies on the earlier filing date of application serial number 09/296,042, filed on April 21, 1999. The attached list of references were submitted to and/or cited by the Office in the prior application and, therefore, are not provided in this application.

This statement is being filed with the application. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: September 8, 2003



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Substitute Form PTO-1449 (Modified)	U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 07977-256002	Application No. New Divisional Application
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Takeshi Fukada	
		Filing Date September 8, 2003	Group Art Unit
(37 CFR §1.98(b))			

U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2001/0018097	08/2001	Itoh			
	AB	4,448,491	05/1984	Okubo			
	AC	5,101,288	03/1992	Ohta et al.			
	AD	5,176,791	01/1993	Itoh et al.			
	AE	5,461,501	10/1995	Sato et al.			
	AF	5,536,950	07/1996	Liu et al.			
	AG	5,652,029	07/1997	Itoh			
	AH	5,686,980	11/1997	Hirayama et al.			
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	AZ	6,217,661	04/2001	Hirose et al.			
	AAA	6,224,952	05/2001	Itoh			

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	

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U.S. Patent Documents							
Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	ABB	6,258,434	07/2001	Hayashi			
	ACC	6,261,634	07/2001	Itoh			
	ADD	6,265,070	07/2001	Itoh			
	AEE	6,423,383	07/2002	Hirose et al.			
	AFF	6,468,617	10/2002	Yamazaki et al.			

Foreign Patent Documents or Published Foreign Patent Applications								
Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation	
							Yes	No
	AGG	03-072711	11/1991	Japan				
	AHH	03-185425	08/1991	Japan				
	AII	04-027691	05/1992	Japan				
	AJJ	10-268360	10/1998	Japan				
	AKK	Hei 11-52	03/1999	Japan				

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	ALL	
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	ANN	
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	APP	
	AQQ	
	ARR	
	ASS	

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